

Simultaneous Microscopic Imaging of Elastic and Thermal Anisotropy

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Simultaneous microscopic imaging of elastic and thermal anisotropy

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Simultaneous imaging of elastic and thermal properties of anisotropic materials with micron (lateral) and nanometer (depth) resolution is presented. This approach employs an ultrafast laser for the generation and detection of thermal and acoustic waves. Demonstrations involving the visualization of thermal waves and surface acoustic waves are presented for single crystal quartz and fused silica substrates sputter coated with chromium films. These images dramatically reveal and contrast the symmetry of thermal and elastic properties and compare favorably with theoretical prediction. This hybrid approach shows great promise to investigate fundamental properties of materials and interfaces on both a low-frequency (elastic wave) and a high-frequency (phonon diffusion) scale.

Accurate knowledge of thermal and elastic properties of materials at nanometer and micron length scales is germane to fully utilizing an increasingly large array of novel materials ranging from micromechanical devices to quantum well structures. For instance, a thorough understanding of thermal and elastic properties of thin metallic and dielectric films is required for effective thermal management and practical structural design in microelectronic and microphotonic devices. A great number of laser-based thermal waves studies¹⁻³ and laser-based acoustic studies⁴⁻⁶ have been conducted to image, separately, the thermal and mechanical properties of materials. Concerning point measurements, Capinski and Maris⁷ have employed an optical pump probe technique to study thermal conductivity in silicon and Hostetler *et al.*⁸ have simultaneously measured the elastic bulk modulus and the thermal diffusivity normal to the surface of thin films by combining picosecond acoustic and thermoreflectance techniques.

In this paper, a laser-based microscope for simultaneously imaging thermal and elastic anisotropy in nanometer-scale thin film-substrate systems is described. This hybrid photothermal-photoacoustic microscope utilizes a mode-locked Ti:Sapphire laser to generate (pump) and image (probe) thermal and surface acoustic waves (SAW's) and has a depth resolution of a few tens of nanometers⁹ and a lateral resolution of a few microns. The laser system is operated at 800 nm, has a repetition rate of 76 MHz, a pulse duration ~ 1 ps, and a pulse energy ~ 0.1 nJ. The pump and probe beams are focused, at normal incidence onto an optically absorbing film from opposite sides of a transparent substrate, through two microscope objectives producing spot sizes $D \sim 3 \mu\text{m}$ [Fig. 1(a)]. The probe leg can be set up either to measure changes in surface reflectivity, ΔR , or to measure a combination of changes in surface reflectivity, ΔR , and optical phase, $\Delta\phi$. The pump light is amplitude modulated using an AOM and lock-in detection is employed. The pump beam is scanned in the x_1 - x_3 plane at a fixed pump-probe delay time, forming an image of lock-in amplitude (A_L) or lock-in phase (ϕ_L). Table I gives a concise description of the various modes of operation that will be considered in this paper. Sorting out the wealth of thermal and elastic property infor-

mation is accomplished by considering the amplitude dependence of each signal component as a function of modulation frequency. The SAW amplitude is related to the thermal gradient in the film imposed by optical absorption of the ultrafast optical pulse and is generally independent of the pump modulation frequency.¹⁰ In contrast, the amplitude of

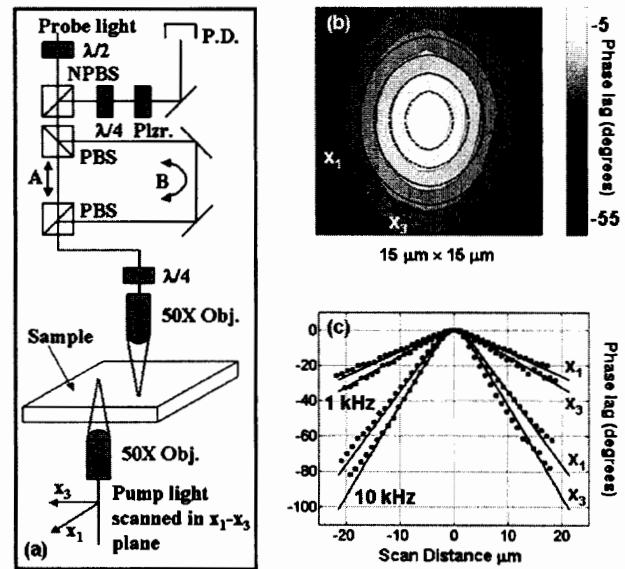


FIG. 1. (a) Experimental setup. The common path differential detection scheme is composed of two beams: one that traverses path A and one that traverses path B. Phase demodulation is achieved using a $\lambda/4$ wave plate and a polarizer placed before the photodetector. (b),(c) The lock-in phase image, ϕ_L , and phase profile of the surface temperature variation were obtained for a 200-nm sputter-coated chromium film on a single crystal quartz substrate (the crystal c axis coincides with the laboratory x_1 axis). The asymmetry in the phase profile and/or image relates to the anisotropic thermal conductivity tensor of the substrate. (b) The phase contour of the surface temperature at 3 kHz. The theoretical results are represented by the dashed lines. (c) The phase profiles at 1 and 10 kHz. The theoretical results are represented by solid lines.

TABLE I. Tabular description of the low frequency (1–10 kHz) and high frequency (>100 kHz) operational modes. TW, AS, and AD refer to thermal wave, acoustic strain, and acoustic displacement, respectively.

MODE OF OPERATION		
	Lock-in amplitude A_L	Lock-in phase φ_L
Change in reflectivity	ΔR (TW) ^a	ΔR (TW) ^a
		[for LFO see Fig. 1(b)]
Interferometer output	ΔR (TW)	ΔR (TW)
	φ_1 (AD) ^b	φ_1 (AD)
	[for HFO see Fig. 2(a)]	[for LFO see Figs. 2(c) and 2(d)]

^aThe change in reflectivity associated with photoelastic coupling, ΔR (AS), is determined from experiment to be more than an order of magnitude smaller than that associated with photothermal coupling, ΔR (TW), for high-frequency operation (HFO), and this disparity is amplified for low-frequency operation (LFO).

^bFor low frequency operation, the lock-in amplitude associated φ_1 (AD) is determined from experiment to be more than an order of magnitude smaller than the lock-in amplitude associated ΔR (TW). For high-frequency operation, these two signals are of comparable magnitude.

the thermal wave component diminishes with increasing modulation frequency.¹¹ Moreover, for a film thickness ~ 100 nm, the film can be considered thermally thin for kHz-range modulation (sampling both film and substrate properties) and thermally thick for MHz-range modulation (predominantly sampling film thermal properties). Thus by judiciously picking the modulation frequency and choosing the appropriate detection scheme, one can either primarily examine thermal waves or surface acoustic waves or simultaneously monitor both.

The first approach considered, Fig. 1, involves imaging the phase lag, φ_1 , of the temperature field due to periodic heating, in the kHz range, of the surface of a single crystal quartz substrate sputter coated with a 200-nm chromium film. In this case the probe beam,¹² which travels solely along path A [Fig. 1(a)], senses small changes in surface reflectivity, ΔR , caused by changes in temperature (modulated reflectance). An image of the phase lag, clearly revealing the presence of thermal anisotropy, is shown in Fig. 1(b). The orientation of the single crystal quartz substrate is specified by a crystal plane perpendicular to the sample normal $(h, k, l) = (20, 25, -9, 1)$ and a crystal direction parallel to the laboratory x_1 axis $[u, v, t, w] = [-14, 13, 1, 0]$.¹³ For the purpose of visualization this orientation roughly corresponds to the crystal c axis coinciding with the laboratory x_1 axis and the direction between the c axis and the hexagonal edge coinciding with the surface normal (laboratory $-x_2$ axis.) In the laboratory reference frame the nonzero components of the conductivity tensor are, κ_{11} , κ_{22} , κ_{33} , κ_{23} . For this orientation the principle section of the representation quadratic is

aligned with the laboratory x_1 and x_3 axes and hence, the phase image exhibits symmetry about the x_1 and x_3 axes. In order to compare the experimental results with theory consider the case of a thin, thermally isotropic, optically absorbing film on a thermally anisotropic, optically transparent substrate. Letting $\tilde{T} = 1/2T \exp(i\omega t) + c.c.$, the heat diffusion equations for the film (subscript f) and substrate (subscript s) are given by

$$\begin{aligned} \kappa_f T_{f,ii} - i\omega \rho_f C_f T_f &= Q_0 e^{-x_1^2 a_1^2 - x_3^2 a_3^2 + \alpha(x_2 - h)} \\ \kappa_{11} T_{s,11} + \kappa_{22} T_{s,22} + \kappa_{33} T_{s,33} + 2\kappa_{23} T_{s,23} - i\omega \rho_s C_s T_s &= 0 \end{aligned} \quad (1)$$

where T , κ , ω , ρ , C , Q_0 , a , h , and α are the temperature, conductivity tensor, modulation frequency, density, specific heat, absorbed laser energy, laser spot size, film thickness, and the optical absorption coefficient, respectively. Note that in order to mimic the experimental setup the pump is introduced from the substrate side of the film. The thermal boundary conditions are given by

$$\kappa_f T_{f,2} = 0|_{x_2=0}, \quad \kappa_f T_{f,2} = 1/R_{th}(T_s - T_f)|_{x_2=h},$$

$$\kappa_f T_{f,2} = \kappa_{22} T_{s,2} + \kappa_{23} T_{s,3}|_{x_2=h}, \quad (2)$$

where R_{th} is the thermal contact resistance between the film and the substrate. The solution to these equations is sought by first applying a double Fourier transform to eliminate dependence on x_1 and x_3 . The resulting ordinary differential equations in x_2 are solved analytically subjected to the boundary conditions, Eq. (2). The transformed solutions are then inverted numerically. The solution is represented by isothermal contour lines at 3 kHz [Fig. 1(b)] and phase profiles at 1 and 10 kHz [Fig. 1(c)]. The variation of a number of material parameters may be considered in order to obtain a fit between experiment and theory.¹⁴ Bulk thermal properties were used for the substrate,¹⁵ and considering the excellent adhesive properties typical of chromium films on silica substrates, the thermal contact resistance was set to zero.¹⁶ The film thickness, 200 nm, was measured using a point-mode picosecond acoustic technique and the spot sizes of the pump and probe, $\sim 3 \mu\text{m}$, were measured using a knife-edge technique. Using bulk values for the film density and specific heat, a fit to within experimental error yielded a thermal conductivity of 40 W/mK, which is less than half the bulk value. This supposition is in keeping with previous studies that reported a decrease in film diffusivity with decreasing film thickness.^{17,18}

The second approach, first presented by Sugawara *et al.*,⁶ employs a common-path interferometric detection scheme¹⁹ for imaging changes in optical phase, $\Delta\varphi_1$, associated with the propagation of acoustic waves along the sample surface. For this differential detection scheme, the optical phase is primarily sensitive to out-of-plane particle velocity.^{6,20} This mode of operation is employed to image surface acoustic waves using a modulation frequency of 1 MHz, Fig. 2(a) (sample specifications and orientation are the same as those

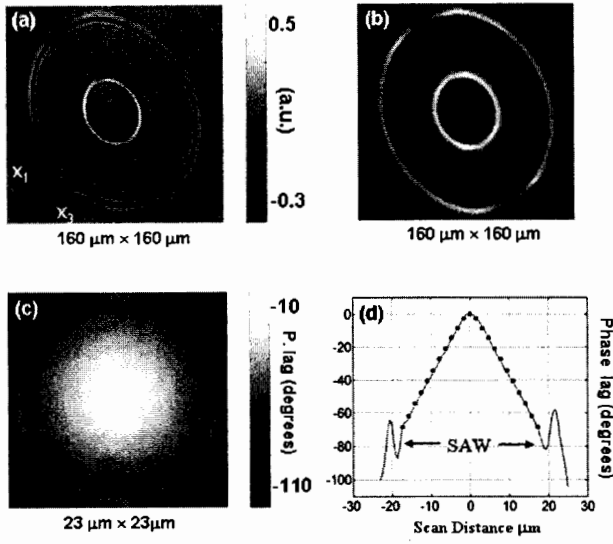


FIG. 2. (a) Interferometric image of variations in lock-in amplitude, A_L , caused by surface acoustic and bulk waves propagating along the surface of a single crystal quartz substrate sputter-coated with a 200-nm chromium film (modulation frequency of 1 MHz). (b) Image derived from theory using an angular spectrum of plane waves. (c) The interferometric image of variations in the lock-in phase, φ_L , caused by thermal and surface acoustic waves (fused silica substrate with a 200 nm chromium film.) (d) The cross section of the phase data presented in (c). The linear variation in the phase near the center of the image relates to the thermal wave. The rapid variation in the phase that forms a halo around the outside of the image is due to interferometric variations in the lock-in phase caused by the surface acoustic wave.

described in relation to Fig. 1). The concentric wave fronts, due to the 76-MHz periodic excitation of the laser source, reveal distinctive phonon focusing.²¹ The thermal wave signal at 1 MHz, which extends only a few microns and is dominated by the thermal properties of the film, is removed to improve the contrast of the surface acoustic wave image. To understand the contributions to this image from the various acoustic modes propagating along the surface of the sample, a relatively simple model of SAW's propagating on a trigonal material with arbitrary orientation was developed. The model accounts for acoustic diffraction from a point source by using an angular spectrum of plane waves.²² The secular equation for acoustic angular dispersion is given by

$$|\Gamma_{jk} - \delta_{jk}\rho v^2| = 0, \quad (3)$$

$$\Gamma_{jk} = k_i k_l C_{ijkl}$$

where C_{ijkl} , ρ , v , and k_i are defined as the elastic stiffness matrix, the density, the acoustic phase velocity, and wave vector. A monochromatic SAW with planar wave fronts is assumed to have the form

$$u_i(\theta_n) = \sum_{n=1}^3 C_n \alpha_i^n e^{[i(k_1 x_1 + k_2 x_2 - \omega t)]}, \quad (4)$$

where C_n are weighting factors, and α_i are the eigenvectors that satisfy the boundary conditions

$$T_{2j} = C_{2jkl} u_{k,l} = 0 \quad \text{at } x_2 = 0. \quad (5)$$

In this formulation, the propagation vector is always along x_1 axis and the crystal is rotated about the surface normal to obtain an angular spectrum of plane waves that is used to approximate a point source

$$v_2 = \frac{1}{N} \sum_{n=1}^N v_2(\theta_n). \quad (6)$$

Instead of a monochromatic SAW, the spatial profile of the out-of-plane particle velocity, v_2 , was assumed to be a unipolar spike,²³ which was convolved with a Gaussian to simulate pulse broadening due to a finite generation spot size. The two concentric surface acoustic waves (separated by 13.15 ns) and the bulk longitudinal wave compare closely with the experimental results, both in shape and in amplitude. Figures 2(a) and 2(b) reveal the rich character of the elastic tensor, namely that the SAW wave front, contrary to the thermal wave phase image, does not exhibit symmetry about the x_1 and x_3 axes. Note that the frequency-dependent dispersion, evident in the outermost SAW wave front, is not considered in the analysis.⁹

The third approach involves simultaneous imaging of surface acoustic and thermal waves. In this capacity, the interferometer measures optical phase changes associated with the propagation of acoustic waves,²⁴ $\Delta\varphi_1$, and reflectivity changes associated with thermal waves, ΔR . To emphasize the consequence of elastic and thermal anisotropy a thermally and elastically isotropic material system is chosen (fused silica substrate–200-nm chromium film.) In order to reveal the thermal character of the substrate, a 3-kHz modulation frequency was selected. At this frequency the thermal wave signal dominates the surface acoustic wave signal; however, by monitoring the lock-in phase, φ_L , instead of the lock-in amplitude, A_L , both the thermal wave and the surface acoustic wave are imaged with comparable signal contrast. The information contained in Fig. 2(c) is best understood by considering a cross section of the phase image in Fig. 2(d). The linear variation in phase near the center of the image relates to the thermal wave component of the signal. The rapid variation in the phase signal at approximately 20 μm from the center [halo around the outside of the image in Fig. 2(c)] is due to interferometric variations in a signal phase caused by the surface acoustic wave. The circular symmetry in the lock-in phase image, Fig. 2(c), is a direct result of thermal and elastic isotropy. It should be noted that to clearly separate thermal and elastic effects, the thermal and acoustic responses must be spatially distinct. In principle this is achieved by changing the optical path length of the pump relative to the probe so as to move the SAW further from the origin. However, the periodic laser excitation at 76 MHz places a limit on the extent to which one is able to

spatially separate the thermal and elastic responses. A numerical simulation of the phase profile is represented by the open squares in Fig. 2(d). As with the chromium film–single crystal quartz sample, a fit to within experimental error was obtained using a film thermal conductivity of 40 W/m K.

In summary, simultaneous imaging of elastic and thermal properties of thin film and/or substrate systems has been presented. This approach uses an ultrafast laser for generation and detection of thermal and acoustic waves and has two distinct modes of operation. The first imaging mode monitors the phase lag of the surface temperature by recording small

temperature-induced changes in surface reflectivity. A second complimentary approach utilizes an interferometric detection scheme to image both the thermal wave phase profile and the out-of-plane particle velocity associated with the propagation of acoustic waves along the sample surface. Visualization of dynamic thermal and elastic properties at the nanometer scale will provide insight into fundamental mechanisms of phonon-related material properties. Future applications will allow detailed investigation of interface properties, such as Kapitza resistance, that are very difficult to make by other means.

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- ¹⁰Large lateral thermal gradients require tight focusing of the pump beam ($<5 \mu\text{m}$). Acoustic modes that reverberate in the film are only significant when the pump and probe are coincident.
- ¹¹The amplitude of the thermal wave diminishes with modulation frequency according to $e^{-x} \sqrt{\omega/2\kappa}$, where κ is the thermal diffusivity.
- ¹²The term pump probe only strictly applies to the acoustic imaging mode of operation.
- ¹³The crystal orientation was obtained using electron backscatter microscopy.
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- ²⁴The optical phase imposed on both signal beams (path A and path B) by the temperature field is identical and hence, there is no thermal wave contribution to the optical phase.